



[10191/1808]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER et al.
Serial No. : 09/889,838
Filed : January 24, 2002
For : PLASMA ETCHING METHOD HAVING PULSED
SUBSTRATE ELECTRODE POWER
Examiner : Allan Olsen
Art Unit : 1763
Confirmation No. : 1541

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on:

Date: December 1, 2003 Reg. No. 22,490

Signature: Richard L. Mayer
Richard L. Mayer

*Resub
42,194*

AMENDMENT

S I R:

In response to the Office Action of July 30, 2003, kindly amend the above-captioned application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

12/08/2003 MBELETE1 00000040 110600 09889838

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02 FC:1202 342.00 DA